TO-1449

U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

DOCKET NO .: 12873-E

SECORPIS: 10 MONON PAPERS 10 MONON PAPERS APPLICANT: GE Fryxell et al.

LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)

			,		FILING DATE 10/26/2001	E:		UP: 17	
U.S. PATENT I	DOCUI	MENTS							
*Examiner Initial		Document Number	Date	Name		Class	Subclass	Filing Date If Appropriate	
			 				 	-	
							NH.	70	
FOREIGN PAT	TENT I	DOCUMENTS					P	H CH (1)	
		Document Number	Date	Cour	Country		3 Zás 3	Thrans Yes	nslation No
							700	100	
						-	·		
			-			+			
	7.		 		,	+			
OTHER REFER	RENCE	ES (including Author, Title	le, Date, Pertinent P	ages, Etc.)					
DSM	Α.	Kruk, M. et al., "A Unified Interpretation of High-Temperature Pore Size Expansion Processes in MCM-41 Mesoporous Silicas", pg. 4590-4598, 1999, J. Phys. Chem. B., 1999, 103, month unknown							
Worm	В	Sayari, A., "Unprecedented Expansion of the Pore Size and Volume of Periodic Mesoporous Silica", pg. 2920-2922, 2000, Angew. Lnt. Ed., 2000, 39, No. 16, month unknown.							
DEM -	C D	Sayari, A., "Unprecedented Expansion of the Pore Size and Volume of Periodic Mesoporous Silica", pg. 2920-2922, 2000, Angewickers. Lnt. Ed., 2000, 39, No. 16, Month unknown. Sayari, A. et al., "New Approaches to Pore Size Engineering of Mesoporous Silica", pg. 1376-1379, 1998, Advance Material Stability of Crosslinking Bonds in Templated Engineered Forms", pg. 1-2, 2000.							
		1							
EXAMINER	<u>~~~</u>	ul Mi	Imi	DATE CONSID		-16.	-03		
*EXAMINER: conformance an	Initial	if reference considered, wo	whether or not citati of this form with n	ion is in conformance vext communication to	with MPEP 609: I			if not in	